In the claims:

1 - 9 (Canceled)

10.(Amended) An ion doping apparatus comprising:
an ion source containing ions of a dopant gas;
an extraction electrode for extracting the ions of said

an acceleration electrode for accelerating the flow of the ions of the dopant gas toward a substrate;

dopant gas to form a flow of ions of the dopant gas;

a substrate holder for holding said substrate; and coils located between said extraction electrode and said acceleration electrode to shape a cross section of said flow into a line shape wherein said cross section is taken along a plane perpendicular to the flow, and wherein a diameter of said coils is monotonically decreased as the flow of said ions extends downstream; and

a means for moving said substrate in an orthogonal direction to an elongation direction of said line shaped cross section.

11 - 20 (Cancelled)

21. (Amended) An ion doping apparatus comprising:

a means for generating an ion current having an elongated cross section;

a means for applying a first magnetic filed coils to focus said ion current, wherein a diameter of said coils is monotonically decreased as a flow of said ion current extends downstream;

a means for applying a second magnetic filed to said ion current in a direction substantially parallel with said elongated cross section of said ion current;

- a slit for cutting a portion of said ion current; and
- a stage which moves in a direction substantially perpendicular to said elongated cross section of said ion current.
- 22. (Original) An ion doping apparatus according to claim 21, further comprising a means for irradiating a laser beam having an elongated cross section.

23. (Canceled)

24. (Amended) An ion doping apparatus according to claim 21, wherein said second magnetic field has a strength between 0.1 to 10 tesla.

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25. (Amended) An ion doping apparatus comprising:

a means for generating an ion current having an elongated cross section;

a means for applying a first magnetic filed coils to focus said ion current, wherein a diameter of said coils is monotonically decreased as a flow of said ion current extends downstream;

a means for accelerating said ion current focused by said first magnetic field;

a means for applying a second magnetic filed to said ion current in a direction substantially parallel with said elongated cross section of said ion current; and

a stage which moves in a direction substantially perpendicular to said elongated cross section of said ion current.

26.(Original) An ion doping apparatus according to claim 25, further comprising a means for irradiating a laser beam having an elongated cross section.

27. (Canceled)

28.(Amended) An ion doping apparatus according to claim 25, wherein said [second] magnetic field has a strength between 0.1 to 10 tesla.

29 - 45 (Canceled)

Please add new claims 46-61 as follows.

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46. (New) An ion doping apparatus comprising:

a means for generating an ion current having an elongated cross section;

a means for applying a first magnetic field to the ion current; and

a means for applying a second magnetic field to the ion current after applying said first magnetic field,

wherein said first magnetic field has a same magnitude as said second magnetic field and has an opposite direction to said second magnetic field.

- 47. (New) An ion doping apparatus according to claim 46, further comprising a coil for focusing said ion current.
- 48. (New) An ion doping apparatus according to claim 46, further comprising a slit between the means for applying the

first magnetic field and the means for applying the second magnetic field.



- 49. (New) An ion doping apparatus according to claim 46, further comprising a means for irradiating a laser beam having an elongated cross section.
 - 50. (New) An ion doping apparatus comprising:
- a means for generating an ion current having an elongated cross section;
- a means for applying a first magnetic field to the ion current;
- a means for applying a second magnetic field to the ion current after applying said first magnetic field; and
- a stage which moves in a direction substantially perpendicular to said elongated cross section of said ion current,

wherein said first magnetic field has a same magnitude as said second magnetic field and has an opposite direction to said second magnetic field.

51. (New) An ion doping apparatus according to claim 50, further comprising a coil for focusing said ion current.

52. (New) An ion doping apparatus according to claim 50, further comprising a slit between the means for applying the first magnetic field and the means for applying the second magnetic field.

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- 53. (New) An ion doping apparatus according to claim 50, further comprising a means for irradiating a laser beam having an elongated cross section.
 - 54. (New) An ion doping apparatus comprising:
- a means for generating an ion current having an elongated cross section; and
- a means for applying a magnetic field and an electric field to said ion current to separate said ion current into at least two ion currents on a mass basis.
- 55. (New) An ion doping apparatus according to claim 54, further comprising a means for irradiating a laser beam having an elongated cross section.
- 56. (New) An ion doping apparatus according to claim 54, wherein said magnetic field has a strength between 0.1 and 10 tesla.

57. (New) An ion doping apparatus according to claim 54, further comprising an accelerating electrode to accelerate only one of said two ion currents.

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- 58. (New) An ion doping apparatus comprising:
- a means for generating an ion current having an elongated cross section;
- a means for applying a magnetic field and an electric field to said ion current to separate said ion current into at least two ion currents on a mass basis; and
- a stage which moves in a direction substantially perpendicular to said elongated cross section of said ion current.
- 59. (New) An ion doping apparatus according to claim 58, further comprising a means for irradiating a laser beam having an elongated cross section.
- 60.(New) An ion doping apparatus according to claim 58, wherein said magnetic field has a strength between 0.1 and 10 tesla.



61.(New) An ion doping apparatus according to claim 58, further comprising an accelerating electrode to accelerate only one of said two ion currents.